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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

SHIMIZU et al

Serial No. 10/735,621



Atty. Ref.: 829-619

Group: 1734

Filed: December 16, 2003

Examiner:

For: PLASMA CVD APPARATUS, AND METHOD FOR
FORMING FILM AND METHOD FOR FORMING
SEMICONDUCTOR DEVICE USING THE SAME

* * * * *

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

As suggested by 37 C.F.R. 1.97, the undersigned attorney brings to the attention of the Patent and Trademark Office the references listed on the attached form PTO-1449.

- All listed documents are attached.
- This application was filed after June 30, 2003 so that copies of U.S. Patent Publications are not required and are not attached.
- Listed foreign patent publications and other documents are enclosed.
- The partial translations were provided to the undersigned by the applicants' foreign representative. The undersigned has no knowledge regarding the pertinency of the partially translated portions vis-á-vis the document as a whole. The partial translations are merely provided for whatever convenience they may be.
- The listed documents were cited in the ISR and copies should have been supplied by WIPO directly to the US PTO. If copies are not timely received from WIPO, please telephone the undersigned so that copies can be timely supplied for the Examiner's consideration in this US National Phase Application.

This is not to be construed as a representation that a search has been made or that no better prior art exists, or that a reference is relevant merely because cited.

The Examiner is requested to initial the attached form PTO-1449 and to return a copy of the initialed document to the undersigned as an indication that the attached references have been considered and made of record.

Respectfully submitted,
NIXON & VANDERHYE P.C.

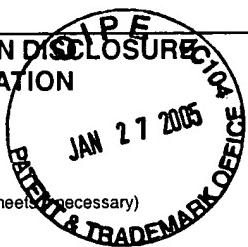
January 27, 2005

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INFORMATION DISCLOSURE CITATION		ATTY. DOCKET NO.	SERIAL NO.
		829-619	10/735,621
		APPLICANT	
		SHIMIZU et al	
		FILING DATE	GROUP
		December 16, 2003	1734

(Use several sheets if necessary)

JAN 21 2005
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PATENT & TRADEMARK OFFICE

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

TRANSLATION

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

	Patent Abstracts of Japan, Japanese publication no. 61163280 A dated July 23, 1986
	Patent Abstracts of Japan, Japanese publication no. 62168870 A dated July 14, 1987
	Patent Abstracts of Japan, Japanese publication no. 63302523 A dated July 8 1988
	Patent Abstracts of Japan, Japanese publication no. 08260145 A dated October 8, 1998 and English translation of the specification
	German Office Action dated October 8, 2004 in corresponding DE application no. 103 58 909.0-45

*Examiner _____ Date Considered _____

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.

Form PTO-FB-A820 (Also PTO-1449)